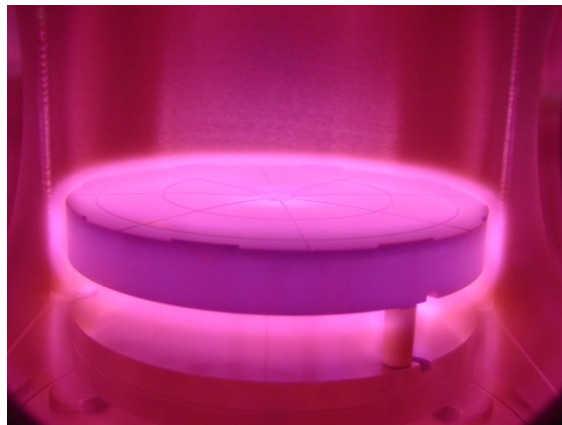


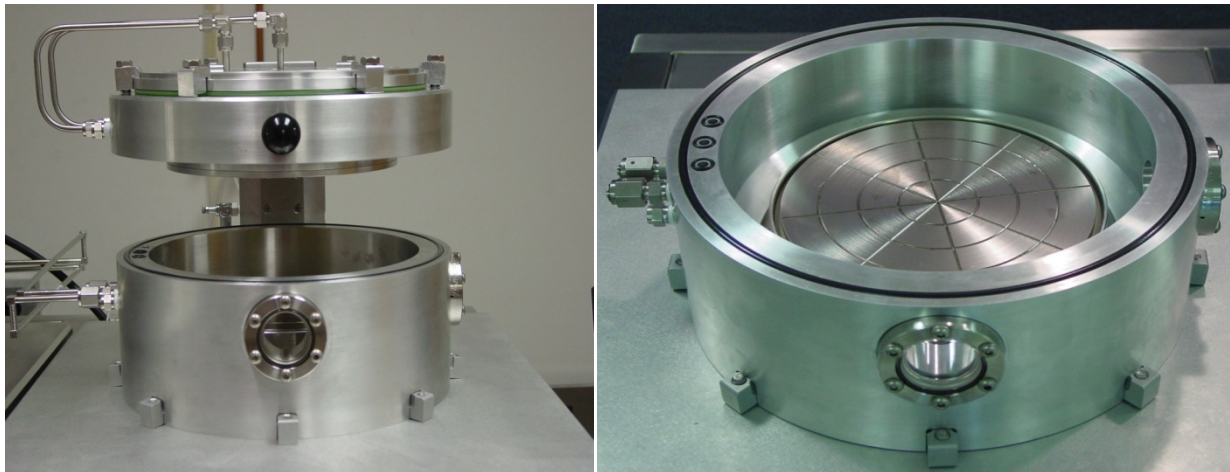
NRP-4000 Equipment



RF Bias Plate



Plasma Source with Shower Head Distribution



RIE Chamber